



Attorney Docket No. 0756-7263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2813
Shunpei YAMAZAKI et al.)	Examiner: Laura Schillinger
Serial No. 10/799,626)	<u>CERTIFICATE OF MAILING</u>
Filed: March 15, 2004)	I hereby certify that this correspondence is
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MANUFACTURING A)	Commissioner for Patents, P.O. Box 1450,
SEMICONDUCTOR DEVICE)	Alexandria, VA 22313-1450, on April 4, 2007.
)	<u>Adrian M. Stampler</u>

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed January 4, 2007, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Filed concurrently herewith is a *Request for Continued Examination*. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on March 15, 2004; September 27, 2005; and March 2, 2006.

A further Information Disclosure Statement is submitted herewith and consideration of this Information Disclosure Statement is respectfully requested.

Claims 1-15, 17-42, 44-46, 48 and 50-55 are pending in the present application. Claims 1-10, 12-14, 19-42, 44-46, 48 and 50-55 have been withdrawn from consideration by the Examiner. (Although the Office Action Summary shows that claims